



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)

YANG, Nian, et al.)

Examiner:

PHAM,

Long

Serial No. 10/758,148)

Group Ad Unit:

2814

Filing Date: January 14, 2004)

Confirmation No.:

4639

For: EFFICIENT USE OF)

WAFER AREA WITH)

DEVICE UNDER THE PAD)

APPROACH)

AMENDMENT AND RESPONSE TO OFFICE ACTION

Hon. Assistant Commissioner for Patents

P.O. Box No. 1450

Alexandria, Virginia 22313-1450

Dear Sir/Madam,

In response to the Office Action mailed August 11th, 2006, Applicant respectfully requests reconsideration of the above referenced patent application. Please amend the above identified application as follows and consider the following remarks for allowance of the above identified patent application.

SERIAL NO. 10/758,148
DOCKET NO. AMD-AF01214

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EXAMINER: PHAM, L
ART UNIT: 2814